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PTO/SB/08A(10-01)

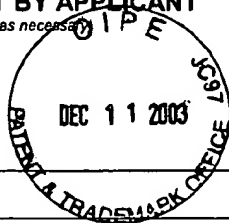
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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| Application Number | 09/256643 |
| Filing Date | February 23, 1999 |
| First Named Inventor | Forbes, Leonard |
| Group Art Unit | 2822 |
| Examiner Name | Trinh, Michael |

Sheet 1 of 2

Attorney Docket No: 303.324US2

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Michael Trinh

DATE CONSIDERED

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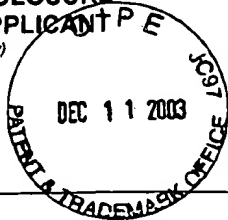
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| Examiner Name | Trinh, Michael |

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